

OCT 21 2004

PAENT & TRADEMARK OFFICE
Attorney Docket No.: 033082 M 184

IFW

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

CONFIRMATION NO.: 3131

Applicant: Shori Mokuo
Application No.: 10/725,372 Art Unit: 3742
Filed: 12/03/2003 Examiner: FUQUA, Shawntina T.
For: SUBSTRATE PROCESSING METHOD AND APPARATUS

AMENDMENT

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed April 21, 2004, Paper No./Mail Date 20040419,
please amend the application as follows and consider the Remarks set forth below.

Included herewith is a Petition to extend the response period for three months, up to and
including October 21, 2004, along with a check for payment of the requisite fee. Please accept
these papers as timely filed on Thursday, October 21, 2004.

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